

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10010548	11/08/2001	216	63	1740	Tran, KB

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1765

**CONTINUING DATA VERIFIED:

None BT

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** FOREIGN APPLICATIONS VERIFIED:

REPUBLIC OF KOREA 2000-69660 11/22/2000

BT

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		YPL-0022	
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no			
Verified and Acknowledged Examiners's initials BT			
TITLE : Method of etching semiconductor device using neutral beam and apparatus for etching the same			

U.S. DEPT. OF COMM. / PAT. & TM. PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim No. 0.0
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawn	Fig. Drawn
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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